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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Technology Center 2100	
	APPLICANT: Rebecca J. Jackman et al.	
	FILING DATE: June 14, 2000	GROUP: Not yet assigned

U.S. PATENT DOCUMENTS

Exam Init	Ref Des	Document No.	Date	Name	Class	Sub Class	FILING DATE If Appropriate

FOREIGN PATENT DOCUMENTS

	Country & Doc. No. (11)	Pub. Date (43)		Class	Sub Class	Translation Yes	No
<i>SL</i>	WO 96/29629	26.09.96	President and Fellows of Harvard College	G03F	A2		

OTHER ART

(Including Author, Title, Date, Pertinent Pages, Publication, Etc.)

<i>SL</i>		Xia et al., <i>Angew. Chem., Int. Ed. Engl.</i> , Vol. 37, 1998, pp. 551-575
<i>SL</i>		Jackman, Rebecca J.; Brittain, Scott T.; Adams, Allen, Prentiss, Mara G.; Whitesides, George M.; "Design and Fabrication of Topologically Complex, Three-Dimensional Microstructures", <i>Science</i> , Vol. 280, June 26, 1988, pp. 2089-2091.
<i>SL</i>		Jackman, Rebecca J.; Brittain, Scott T.; Whitesides, George M.; "Fabrication of Three-Dimensional Microstructures by Electrochemically Welding Structures Formed by Microcontact Printing on Planar and Curved Substrates", <i>J. Microelectromechanical Systems</i> , Vol. 7, No. 2, June, 1998, pp. 261-266.
<i>SL</i>		Jackman, Rebecca J.; Brittain, Scott T.; Adams, Allan; Wu, Hongkai; Prentiss, Mara G.; Whitesides, Sue; Whitesides, George M.; "Three-Dimensional Metallic Microstructures Fabricated by Soft Lithography and Microelectrodeposition", <i>Langmuir</i> , Vol. 15, No. 3, 1999, pp. 826-836 (published on Web 1/14/1999).

EXAMINER

DATE CONSIDERED

02/12/2001

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered.